



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Tetsuhiro Iwai, et al.  
Appln. No. : 10/621,497  
Filed : July 17, 2003  
Title : PLASMA PROCESSING APPARATUS AND PLASMA  
PROCESSING METHOD

Conf. No. : 2610  
TC/A.U. : 1765  
Examiner : Lan Vinh

Customer No. : 000,116  
Docket No. : 35908

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT "C"**

Sir:

This amendment is filed in response to the Office Action dated June 9, 2005 (Paper No. 060205). The three-month period for responding to the Office Action expires on September 9, 2005.

Please amend the above-identified application in the following manner.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

**Suzanne B. Gagnon**

Name of Attorney for Applicant(s)

Signature of Attorney

**August 31, 2005**

Date